



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Michael E. Fossey et al. Art Unit : 2877
Serial No. : 10/601,698 Examiner : Unknown
Filed : June 24, 2003
Title : WAFER INSPECTION SYSTEM FOR DISTINGUISHING PITS AND
PARTICLES

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

NOTICE OF RELATED LITIGATION

In accordance with MPEP 2001.06(c), Applicants call attention to a pending litigation that is related to the subject matter of this application. In a complaint filed October 11, 2000, and an amended complaint filed January 30, 2002, ADE Corporation, the assignee of this application, asserted infringement of the following U.S. patents assigned to them: 6,118,525 and 6,292,259. U.S. Patent Nos. 6,118,525 and 6,292,259 resulted from applications of which this application is a continuation.

Applicants intend to file an information disclosure statement including information from this litigation shortly.

This statement is being filed before the receipt of a first Office action on the merits. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 2/2/04



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